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PATENT

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APR 12 2002

John T. Pienkos, Reg. No. 42,997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Richard D. Harris
Application No.: 09/843,545
Filed: April 26, 2001
For: METHOD FOR FABRICATING AN ISOLATED
MICROELECTROMECHANICAL SYSTEM
(MEMS) DEVICE USING AN INTERNAL VOID
Group Art Unit: 2812
Examiner: --
Atty. Docket No.: 110003.97460

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§1.97 AND 1.98

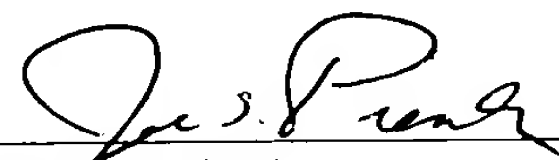
Commissioner for Patents
Washington, D.C. 20231

Sir:

This paper is being presented for filing in the above case pursuant to Rules 97 and 98 of the Rules of Practice. A Form PTO-1449 "Information Disclosure Statement by Applicant" is attached which lists a reference cited and a copy of the reference is enclosed.

No additional fees for filing this paper are believed to be due. However, the Commissioner is hereby authorized to charge any additional fees due or to credit any overpayment to deposit account no. 17-0055.

Respectfully submitted,


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